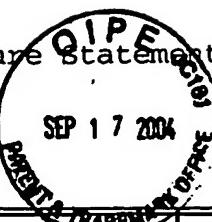


Information Disclosure Statement
USSN 10/774,002
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Page 4



Form PTO-1449 (Modified)	ATTY DOCKET NO. B-4231 618915-3	U.S. SERIAL NO. 10/774,002
LIST OF PATENTS AND PUBLICATIONS STATEMENT	APPLICANTS David S. SUMIDA, et al.	
	FILING DATE February 6, 2004	GROUP not yet assigned

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUB-CLASS	FILING DATE or 102(e) DATE IF APPROPRIATE
AC	10/774,001		Pepper et al.			2/6/2004
	3,786,368	1/1974	Bjorkholm et al.	331	94.5	
	3,970,960	7/1976	Mollenauer	331	94.5 F	
	3,992,681	11/1976	Haun, Jr. et al.	331	94.5 M	
	4,249,141	2/1981	Brown et al.	331	94.5 F	
	4,757,268	7/1988	Abrams et al.	330	4.3	
	5,754,572	5/1998	Pinto et al.	372	20	
AC	5,926,494	7/1999	Pepper	372	70	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Gisen, A., et al., "Scalable Concept for Diode-Pumped High Power Solid-State Lasers," <i>Applied Physics B</i> 58, Springer-Verlag, pp. 365-372 (1994).
Le, H.Q., et al., "Scalable High-Power Optically Pumped GaAs Laser," <i>Appl. Phys. Lett.</i> , Vol. 58, No. 18, pp. 1967-1969 (1991).
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Wagner, J.W., et al., "Theoretical Noise-Limited Sensitivity of Classical Interferometry," <i>J. Opt. Soc. Am. B</i> , Vol. 4, No. 8, pp. 1316-1326 (August 1987).
Zhang, L., et al., "Characterization of Ion Implanted Waveguides in Nd:YAG," <i>J. Appl. Phys.</i> , Vol. 69, No. 6, pp. 3440-3446 (March 15, 1991).

EXAMINER	DATE CONSIDERED
A. Rodriguez	6-16-06

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.